

**PATENT** 

Docket No.	IL-10680

**Commissioner for Patents** Washington, DC 20231

			NEW APPLICATIO	N TRANSMITTAL	o
	nsmitte I <b>R. Au</b> l		rith for filing is the patent	application of Inventor(s):	61653 61653
For	(title):	High	Power Laser Having a Tr	ivalent Titanium Liquid Host	9/60
1.	Type	of App	olication		jo
		This r	new application is for an o	riginal patent.	
		This r	new application is a:		
			Division		
			Continuation		
			Continuation-in-part (Cl	IP)	
2.	Bene	fit of P	rior U.S. Application(s) (3	35 USC 120)	
				smitted claims the benefit of prior	
		U.S. a	pplication(s):	•	
3.	□ Below		nder 35 U.S.C. 119(e) of I	United States provisional applicati	on(s) liste
	Appli	cation S	erial No. Fi	ling Date	
4.	Pape	rs encl	sed which are required f	for filing Date Under 37 CFR 1.53(	b).
	16	Pages	of specification		
	3	Pages	of claims		
	1	Pages	of abstract		
	6		of drawings		

#### Additional papers enclosed 5.

Preliminary Amendment
Information Disclosure Statement
Form PTO-1449

formal informal

6.	Dog	aration	or oath
n.	Deci	aration	or oatn

- Enclosed and executed by
  - inventors
  - □ legal representative of inventor(s) 37 CFR 1.42 or 1.43
- □ Not Enclosed

## 7. Assignment

- An assignment of the invention to <u>The Regents of the University of California</u>.
  - is attached
  - □ will follow

## 8. Certified Copy

Certified copy(ies) of application(s)

(country)	(application no.)	(filed)
(country)	(application no.)	(filed)

from which priority is claimed

- $\Box$  is(are) attached.
- □ will follow

#### 9. Fee Calculation

		CLAIMS AS	FILED					
Type of Claim	Number	Included in	Number		Rate	e		Total Fee
	Filed	Basic Fee	Extra					
Total Claims	9	-20 =		x	\$18	=	\$ .	
Independent Claims	3	-3 =		x	\$78	=	\$ .	
		M	lultiple Cla	ims		=	\$_	
		$\mathbf{B}_{i}$	asic Filing I	Fee		=	\$ _	690.00
		Sı	ıb-Total			=	\$	690.00
		S	mall Entity	Fili	ng Fe	e=	\$	345.00

LLNL Patent Group Page 2 of 3

10.	Smal	l Entity Statement(s)				
		Verified Statement t 1.27 is attached.	that this is a fi	iling by small entity unde	er 37 CFR	R 1.9 and
		Filing Fee Calculation	on (50% of reg	gular filing fee)	\$	345.00
11.	Fee F	ayment				
		Not Enclosed				
		Enclosed (See Accord	unt No. Belov	v)		
		Total Basic I	iling Fees To	Be Paid	\$	345.00
12.	Meth	od of Payment of Fe	es			
		Check in the Amou	nt of \$			
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Date	ed:	September 13, 2000		Eddie E. Scott		
				Patent Attorney	20	
				Registration No. 25,22	20	
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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Earl R. Ault Attorney Docket No. : IL-10680

Serial No. : Art Unit:

Filed : Examiner:

For : High Power Laser Having a Trivalent Titanium Liquid Host

Commissioner for Patents Box PATENT APPLICATION Washington, D.C. 20231

## **EXPRESS MAIL CERTIFICATE**

"Express Mail" label number <u>EM012648557US</u>

Date of Deposit September 14, 2000

I hereby certify that the following attached

Express Mail Certificate; and return postcard;

New Application Transmittal (original and one copy); Verified Statement Claiming Small Entity Status;

Recordation Cover Sheet and Assignment;

Application (Specification 16 pages, Claims 3 pages, Abstract 1 page); Six (6) sheets formal drawings;

Declaration/Power of Attorney

is being deposited with the United States Postal Service "Express Mail Post Office to addressee" service under 37 CFR 1.10 on the date indicated above and is addressed to the Box PATENT APPLICATION, Commissioner for Patents, Washington, D.C. 20231.

Terry K. Contreras

(Type or print name of person mailing paper)

(Signature of person mailing paper or fee)

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Earl R. Ault	Docket No.: IL-10680
Serial No.	:		Art Unit :
Filed	:		Batch No. :
For	:	High Power Laser Having a Trivalent Titanium Liquid Host	Examiner :
		O STATEMENT (DECLARATION) CLA S [37 CFR 1.9 (f) and 1.27(d)] - NONPRC	
		are that I am an official empowered to dentified below:	act on behalf of the nonprofit
	( :	The Regents of the University of Californ Office of General Counsel 1111 Franklin Street Oakland, CA 94607-5200	ia
TYPE OF	OR	GANIZATION	
XUni	iver	sity or other Institute of Higher Educatio	n
nonprofit fees under invention	org r Se enti	lare that the nonprofit organization id anization as defined in 37 CFR 1.9(e) fo ction 41(a) and (b) of Title 35, United S tled <u>High Power Laser Having a Trivalent T</u> Earl R. Ault	r purposes of paying reduced tates Code with regard to the
described	in		
x		the specification filed herewith.	
<u></u>		application serial no	, filed
		natent no issu	ed .

I hereby declare that rights under contract or law have been conveyed to and remain with the nonprofit organization with regard to the above identified invention, except for a license to a Federal Agency pursuant to 35 USC 202(c) (4).

Each person, concern or organization to which I have assigned, granted, conveyed, or licensed or am under an obligation under contract or law to assign, grant, convey, or license any rights in the invention is listed below:

X no such person, concern, or organization

I acknowledge the duty to file, in this application or patent, notification of any change in status resulting in loss of entitlement to small entity status prior to paying, or at the time of paying, the earliest of the issue fee or any maintenance fee due after the date on which status as a small entity is no longer appropriate. (37 CFR 1.28(b))

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true: and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application, any patent issuing thereon, or any patent to which this verified statement is directed.

## JANET G. TULK

Laboratory Counsel Lawrence Livermore National Laboratory 7000 East Avenue, L-701 Livermore, CA 94551

JANET G. TULK

Data

# HIGH POWER LASER HAVING A TRIVALENT TITANIUM LIQUID HOST

BY

Earl R. Ault (USA) 7000 Tesla Road Livermore, CA 94550

## HIGH POWER LASER HAVING A TRIVALENT TITANIUM LIQUID HOST

The United States Government has rights in this invention pursuant to Contract No. W-7405-ENG-48 between the United States

Department of Energy and the University of California for the operation of Lawrence Livermore National Laboratory.

## BACKGROUND OF THE INVENTION

#### Field of Endeavor

The present invention relates to lasers, and more particularly to a high power laser with a trivalent titanium liquid host.

## State of Technology

There are many applications for very high average optical power lasers. These applications include power beaming, laser guide stars, illuminators, material processing, remote sensing, laser weapons, and tactical defense systems. A problem in high power laser applications is the lack of suitable sources of radiation with high beam quality. For weapons applications the Chemical Oxygen Iodine Laser (COIL) seems to show

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promise, but it is a complex and expensive system for use in the 10-100 kW regime. Also at 1.3 micron, it is not useful for use with solar cells and is not readily frequency converted to short wavelengths as would be required for guide stars. Free electron lasers (FELs) have been touted as a solution for decades but have failed to demonstrate useful output powers and acceptable system efficiencies at the wavelengths of interest. Proposed high efficiency recirculating FELs, in which the beam energy is recovered after exiting the wiggler, have been unimpressive due to the poor emittance of the recovered beam and the resulting energy loss in the accelerator and storage ring. To date FELs have yet to produce multi-kilo watt beams at any wavelength and require an immense physical plant to produce even a few watts in the infrared.

Neodymium and other metal ions embedded in a variety of glassy and crystal hosts have been the mainstay of commercial lasers and fusion lasers for decades. However, when these devices are applied to multi-kilowatt applications results have been disappointing. Despite of the development of many complex and expensive systems, practical operation at much greater than one kilowatt with beams near the diffraction limit has not been demonstrated. This complex problem is essentially an issue of thermal management. Solids must have the heat conducted away and at high heat loads this leads to unavoidable temperature gradients. These gradients destroy optical beam quality and can lead to fracture of the media. To cope

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with these problems designs have recently been put forward that use reduced crystal thickness to improve heat conduction. This approach has limited excited volume, and a complex optical train must be constructed to give the volume needed to produce high average powers. It is not clear if closure can be reached with these designs, since each added component adds additional optical aberrations and opportunities for catastrophic optical damage.

Fluids, on the other hand, have the advantage that when the media gets hot it can be removed from the optical path to a place where it can be cooled. A liquid laser is shown and described in U. S. Patent No. 3,717,825 to Carl Zeiss-Stiftung, Wuerttemburg, Federal Republic of Germany, patented February 20, 1973. This patent shows a dyestuff laser provided with a liquid guiding chamber through which circulates a cooled laser liquid. The laser is provided with a U-shaped laser active zone formed by a light transmitting longitudinal cap into which extends a tongue forming in said cap a U-shaped zone of uniform cross section. This U-shaped laser active zone is disposed in a focal line of an elliptically shaped pump light reflector while a source of pump light is disposed in the other focal line.

Fluids do not exhibit birefringence so all polarization options are available, have high optical damage thresholds, and do not permanently damage if the threshold is exceeded. Compared to solid laser media fluids are quite inexpensive. U. S. Patent No. 3,931,594 to Fritz Peter Schafer, assigned to Max-Planck-Gesellschaft zur Forderung der Wissenschaften e.V., patented

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January 6, 1976, shows a transverse-flow cell for a laser. The cell of a liquid laser is defined between the rounded, parallel edges four coaxial cylinder sectors of fused quartz. The narrow gaps circumferentially bounded by the flat, converging side faces of the sectors provide conduits for rapid flow of dye liquid into and out of the cell which extend over the full axial length of the cell. The light of a flash tube is directed toward the cell through the cylindrically arcuate outer face of each sector.

U. S. Patent No. 3,740,665 to Irving Itzkan, assigned to Avco Corporation, patented June 19, 1973, shows a transverse flowing liquid laser. Stimulated emission of radiation (laser action) is produced in materials generally classed as dyes. These dyes are dissolved in a liquid solution. A quantity of dye in a flowing liquid solution in a module or cavity is pumped or excited by a laser beam radiating in the ultraviolet region which is focused to a line with a cylindrical lens. A rectangular cross sectional beam of such radiation is produced by a pulsed crossed field nitrogen gas laser. The focused line which is transverse to the beam produced by the exciting laser, and transverse to the direction of the flowing dye, lies near the surface of the dye material in the cell and is substantially as long as the cell is wide. The cell lies within an intensifying optical cavity which may be formed by a 100 percent reflecting mirror and a partially reflecting mirror both perpendicular to the line of focus of the pumping radiation. The stimulated emission from

the dye material is characterized by a short pulse width and a little loss of energy between the two lasers.

One of the most highly developed fluid lasers is the AVLIS dye laser AVLIS (Atomic Vapor Laser Isotope Separation). Development of this family of lasers took place at Lawrence Livermore National Laboratory over the period of 1972 to 1999. It can produce single aperture powers approaching 3 kW with nearly diffraction limited beams. However, these lasers do not store optical energy and must be excited by an even higher peak power pump laser, albeit with much lower beam quality requirements. Rare earth ion based lasers have the advantage of long florescent lifetimes, so they require lower peak pump powers.

Liquid hosts containing rare earth have been considered. However, such devices were flash lamp driven leading to unacceptably large temperature gradients in the fluid and their poor beam quality. U. S. Patent No. 3,931,594 to Erhard J. Schmitschek, assigned The United States of America as represented by the Secretary of the Navy, patented December 18, 1973, shows a liquid lasing composition consisting essentially of neodymium (III) phosphorus dichloridate, retained in solution with phosphorus oxychloride by the addition of a Lewis acid.

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#### SUMMARY OF THE INVENTION

In accordance with the present invention, a laser system is provided that will produce high optical power with high beam quality. The present invention utilizes trivalent titanium ions dissolved in a liquid host to provide powerful laser action in the 800 to 900 nm region.

It has been proposed to use liquid lasers based on Nd<sup>+3</sup> ions. However, at the lasing wavelength of 1.053 micron, solar cells, one of the primary receivers of such radiation, are limited to those based on silicon. Moreover, radiation damaged silicon cells and gallium arsenide cells perform poorly at this wevelength. What is needed is the equivalent of a Ti:Sapphire solid state laser that is in the liquid state that can be pumped with presently available semiconductor diodes at around 800 nm. The present invention utilizing trivalent titanium ions dissolved in a liquid host provides the answer.

In an embodiment of the present invention a Ti<sup>+3</sup> bases liquid is optically excited by a semiconductor diode. Since the host is a liquid, it can be removed from the optical cavity when it becomes heated avoiding the inevitable optical distortion and birefringence common to glass and crystal hosts. The Ti<sup>+3</sup> bases liquid laser, operating in the near infrared at 800-900 nm, is capable of producing tens of kilowatts of cw power with good beam quality. Applications include power beaming, laser guide stars, illuminators,

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material processing, remote sensing, laser weapons, and tactical defense systems.

Additional aspects, advantages, and features of the invention are set forth in part in the following description. Various aspects, advantages, and features of the invention will become apparent to those skilled in the art upon examination of the description and by practice of the invention.

## BRIEF DESCRIPTION OF THE DRAWINGS

FIG. 1 illustrates an embodiment of a laser constructed in accordance with the present invention.

FIG. 2 shows the conversion efficiency of several solar cell materials as a function of illumination wavelength.

FIG. 3A shows Glass I Al(PO3):Ti<sup>+3</sup>.

FIG. 3B shows Glass II Al(PO3):Ti<sup>+3</sup>.

FIG. 3C shows Glass III Gallium Phosphate.

FIG. 3D shows Ti:Sapphire.

FIG. 4A is a graph of laser performance.

FIG. 4B is a graph of output coupler dependence.

FIG. 4C is a graph of relative pump light intensity.

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## DETAILED DESCRIPTION OF THE INVENTION

There are many applications for high power lasers. These applications include power beaming, laser guide stars, illuminators, material processing, remote sensing, laser weapons, and tactical defense systems. In power beaming, laser radiation is transported to a remote location where it is converted to electrical power or for other uses such as propulsion. Tens to hundreds of kilowatts of laser light with sufficient beam quality are required for the applications of interest. The wavelength requirements of the receiver as well as the transparency of the atmosphere are prime considerations.

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Power beaming using high power lasers to the lunar surface to support a colony has been considered. Power beaming to satellites at Geosynchronous Earth Orbit (GEO) has been considered. The uses of power beaming to GEO include battery charging, space tugs to change orbit, and for primary power to increase the transponder capacity. NASA has initiated a program involving a high altitude aircraft powered by solar power for the purpose of Environmental Research and Sensor Technology (ERAST). In transmitting power from earth to the high altitude aircraft, a photovoltaic (PV) cell array is located on the underside of the high altitude aircraft to be accessible from laser radiation from the earth. The PV cell array is mounted on a part of the high altitude aircraft which is also transparent to solar radiation from above. The PV cells are sufficiently thin so that solar radiation

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can also contribute to the power conversion; and in case of interruption of the laser power beaming, the solar radiation can provide backup power.

Referring now to the drawings and in particular to FIG. 1, an embodiment of a laser constructed in accordance with the present invention is illustrated. The laser system is generally designated by the reference numeral 20. A liquid lasing medium is circulated through a closed loop. The closed loop is generally designated by the reference numeral 21. The closed loop 21, filled with a Ti<sup>+3</sup> bases liquid, circulates the liquid into and out of a pair of lasing chambers 22 and 22′. A pair of semiconductor pumping devices 23 and 23′ are located within the lasing chambers 22 and 22′. The semiconductor pumping devices 23 and 23′ are used to optically excite the liquid lasing medium within the optical cavities, lasing chambers 22 and 22′. The semiconductor pumping devices 23 and 23′ can be a semiconductor diode lasers or light emitting diodes. The pump 24 circulates the lasing liquid through a pair of heat exchangers/flow conditioners 25 and 25′, a static pressurizer 26, and the optical cavities 22 and 22′.

Windows at each end of the channel define an excitation volume. Two gain blocks with opposite flow directions are used to compensate for the static optical wedge induced by fluid heating. The linear component, or optical wedge, that builds up in the liquid as it flows past the pump windows is predictable and steady. By arranging two cells in series in the laser cavity having opposite flow directions allows the wedge to be canceled.

The present invention utilizes trivalent titanium ions dissolved in a liquid host. The shifts in absorption and emission seen when this ion is placed in glasses demonstrate it is possible to achieve powerful laser action in the 800 to 900 nm region when this ion is excited by 808 nm semiconductor diodes. Solar cells are one of the primary receivers of such radiation at 1.053 micron. What is needed is the equivalent of a Ti:Sapphire solid state laser that is in the liquid state that can be pumped with presently available semiconductor diodes at around 800 nm. The present invention utilizing trivalent titanium ions dissolved in a liquid host provides the answer.

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The conversion efficiency of several solar cell materials as a function of illumination wavelength is show in FIG. 2. This graph is based on work done by Anspaugh, Mueller, Lowe, and Landis at NASA-JPL (Results of Illuminating Various Solar Cells with Pulsed Laser Beams, Anspaugh, Mueller, Lowe, and Landis, NASA-JPL Publication 92-25.) What is needed for this application is a powerful cw laser with a wavelength less than 900 nm. Furthermore, it is very desirable for this laser to be pumped with semiconductor diodes for efficiency and thermal management reasons. A liquid host is preferred. Nearly all lasers in this part of the spectrum are solid state lasers with the exception of near infrared dye lasers.

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Trivalent transition metals have been studied in crystals and glasses. Trivalent chromium, being an example, performs well in a number of hosts. The requirement of relatively short pump wavelengths (in the 600 to

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700 nm range) makes diode pumping possible but difficult because of the lower level of development of efficient high power semiconductor diode bars in this spectral region. The three level Cr<sup>+3</sup> laser also requires high pump intensities in spite of the long fluorescent lifetime (~3 ms in ruby for example). Trivalent chromium in glasses shows broad emission and absorption peaks shifted to the red of ruby and may possibly act more like a four level system and therefore be easier to drive to threshold. The center emission wavelength is quite sensitive to host composition, but operation at 1000 nm is shown with a 200 nm half width for the Silicate formulation. However, the peak absorption lies at 650 nm and is weak at 800 nm.

The optical properties of Ti<sup>+3</sup> in glasses was promising. Under these conditions, Titanium offers reasonable absorption near 800 nm and strong emission from 800 nm to over 900 nm. By correspondence, since aprotic liquids can host complexed Nd<sup>+3</sup> ions and yield laser performance very similar to glasses, it is considered possible to maintain Ti<sup>+3</sup> in a liquid laser solution.

Aprotic liquid Nd<sup>+3</sup> lasers behave spectrally and kinetically very much like a glass laser, but the medium can flow for cooling. Stark broadening of the ion spectra to allow the laser transitions occurs in the disordered liquid by virtue of solvophilic ligands (such as GaCl<sub>3</sub>, SnCl<sub>4</sub>, etc.) forming complexes with the target metal ion. This process is analogous to the

splitting caused by the disordered local fields arising in the vicinity of the ion imbedded in glass.

Interest in glasses stems from the close analogy to liquids. Of interest here is the fact that the glass matrix gives rise to a significant broadening of the absorption band and shifts in the absorption peak and emission peak compared to a Sapphire matrix so that diode pumping at 808 nm may be possible, see FIG. 3A, 3B, 3C, and 3D for comparisons.

FIG. 3A, showing Glass I Al(PO3):Ti<sup>+3</sup>, is very attractive for 808 nm diode pumping and lasing at 900 nm. Other formulations have Glass II shown in FIG. 3B which is reminiscent of Ti:Sapphire, shown in FIG. 3D. FIG. 3C is shifted too far to the blue and is actually worse than Ti:Sapphire. Excited state lifetimes are also improved in the glasses compared to corundum. It is established that glass hosts for Ti<sup>+3</sup> offer the possibility of laser action. The interest in glass is as a model for possible liquid hosts.

There are three considerations in choosing a liquid host. First there must be sufficient Stark splitting from the solvating ligand to make the ion optically active. This is the case in the aprotic Nd systems. Next, the liquid must not quench the excited state of the ion. As we have seen with Nd, hydrogen bonds are effective in quenching the laser upper level forcing the use of inorganic solvents. Finally, the solution must probably be acidic to preserve the valence of the ion. Lewis acids are the likely medium. Most solvents explored for use in liquid lasers are based on halides or oxychlorides and employ sulfur or

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phosphorus as the anion in the +6 valence state. The exception is thionyl chloride where sulfur is in the +4 state. In the case of  ${\rm Ti}^{+3}$ ,  ${\rm Mn}^{+3}$ , and  ${\rm UO}_2{\rm Cl}_2$ , thionyl chloride is unsuitable because it can change valence and reduce  ${\rm Ti}^{+3}$  to  ${\rm Ti}^{+4}$ .

The laser is modeled in FIGS. 4A, 4B and 4C. This tells us what parameters must be included and what performance to expect depending on assumptions. The model was developed for the Nd liquid lasers. This is a simple spread sheet model based on Koechner's cw four level oscillator and includes the temperature rise of the liquid and the flow requirements.

A solution to the steady state power oscillator in terms of system efficiencies and fundamental optical parameters is used, including the following:

$$P_{out} = \eta_{slope} (P_{in} - P_{TH})$$
 and

$$P_{_{TH}} = \ (T + L) \ A \ I_{_{sat}} \ / (\eta_{_{pump}} \eta_{_{trans}} \eta_{_{abs}} \ \eta_{_{upper}} \ \eta_{_{beam}}) \text{,} \label{eq:pump}$$

where  $P_{in}$  is the input electrical power to the pump source,  $\eta_{slope}$  is the slope efficiency,  $I_{sat}$ , is the saturation intensity, and A is the cross sectional area of the gain media. The slope efficiency is a cascade of practical efficiencies and is defined by,

$$\eta_{\text{slope}} = (T/(T-L)) \eta_{\text{pump}} \eta_{\text{trans}} \eta_{\text{abs}} \eta_{\text{upper}} \eta_{\text{beam}}$$

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 $\eta_{\ \ \text{\tiny pump}}$  is the efficiency with which the pump source converts electricity into photons

 $\eta$   $_{\mbox{\tiny trans}}$  is the pump light transport efficiency

 $\eta$   $_{\mbox{\tiny abs}}$  is the absorption fraction of the pump energy

 $\eta_{\ \ \text{upper}}$  is the product of the quantum efficiency and the pump to laser Stokes loss

 $\eta_{_{beam}}$  is the factor that accounts for the light distribution across the laser beam. T and L are the output coupler and internal cavity losses.

Referring again to FIGURES 4A, 4B and 4C spread sheet models are shown that allows parameters to be varied using the above formulation. FIG. 4A shows laser performance, FIG. 4B shows output coupler dependence, and FIG. 4C shows relative pump light intensity. Using an excited state lifetime of  $10~\mu sec$ , 808~nm diode pump light, and estimating the stimulated emission cross section to be  $1.7~X~10^{-19}~cm^2$ , an output power of 20~kW can be obtained with about 70~kW of diode power. The model assumes a simple resonator to estimate the energetics. In practice an unstable resonator would be used for beam quality reasons.

In estimating the stimulated emission cross section either a

Lorentzian or Gaussian line shape centered at the peak emission wavelength

was assumed. Either choice gives about the same result. Then following

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Verdeyen's treatment on page 154 of his book "Laser Electronics" for a homogeneous broadened transition, the cross section depends only on the line shape factor and the Einstein A coefficient. Using the width of the fluorescence curve for  $\mathrm{Ti}^{+3}$  in glass (200 nm) and the transition rate of  $\mathrm{10}^{5}$  per second, also for glass, the value of  $\mathrm{1.7~X~10^{-19}~cm^{2}}$  is obtained. Using the same procedure with values of fluorescence width and lifetime published for  $\mathrm{Ti}$ :Sapphire gives  $\mathrm{3.75~x~10^{-19}~cm^{2}}$ , in reasonable agreement with the published polarization dependent values of  $\mathrm{2-4~10^{-19}~cm^{2}}$ .

It is believed that enough Ti<sup>+3</sup> can be put into solution to achieve the pump absorptance assumed,  $4 \, \mathrm{cm}^{-1}$ , without leaving too much Ti<sup>+4</sup> around to form complexes with Ti<sup>+3</sup> giving rise to absorption at the laser wavelength. This was a common problem in early Ti:Sapphire lasers. It is further believed that this much Ti<sup>+3</sup> can actually be put into solution. Lattice considerations and solubility limits the dissolution of metal compounds in crystals and glasses. Again from the literature on glass, pump absorption of around  $0.5 \, \mathrm{cm}^{-1}$  at 808 nm for a doping concentration of 0.25% are reported. A value ten times larger to get the deposited pump power high enough to get well over threshold isbelieved. This corresponds to  $2.5 \, \mathrm{weight}$  percent dissolved in the liquid. Concentrations exceeding one mole per liter of NdCl<sub>3</sub> in SeOCl<sub>2</sub> have been demonstrated. This is 16 weight percent or  $6.4 \, \mathrm{times}$  the proposed doping.

Other features of the model dealing with thermal management are similar to the neodymium lasers. Input powers are somewhat larger due to the lower projected stimulated cross section and shorter lifetime. Two cells are used with opposite flow directions to cancel the linear optical wedge induced by waste heat in the fluid. The projected phase error of the output beam is about 0.4 waves peak to peak after correction with a single actuator deformable mirror.

## THE INVENTION CLAIMED IS

- 1. A laser, comprising:
- a lasing chamber,
- a semiconductor pumping device within said lasing chamber, and trivalent titanium ions dissolved in a liquid host within said lasing chamber.
- 2. The laser of claim 1 including a circulation system for circulating said trivalent titanium ions dissolved in a liquid host into and out of said lasing chamber.
- 3. The laser of claim 2 wherein said circulation system includes a closed loop for circulating said trivalent titanium ions dissolved in a liquid host into and out of said lasing chamber, a pump, and a heat exchanger.
- 4. The laser of claim 2 including a system for correcting the thermally induced optical phase errors.

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5. The laser system of claim 4 wherein said system for correcting the thermally induced optical phase errors includes a system for circulating said liquid host through a closed loop so that the liquid host is divided into two equal lengths along the laser propagation direction and placed in series in the lasing chamber with the fluid flows arranged in opposite directions.

6. A laser method comprising:

providing a lasing liquid

containing trivalent titanium ions dissolved in a liquid host, and

optically exciting said lasing liquid by a semiconductor pumping device to provide a powerful laser beam.

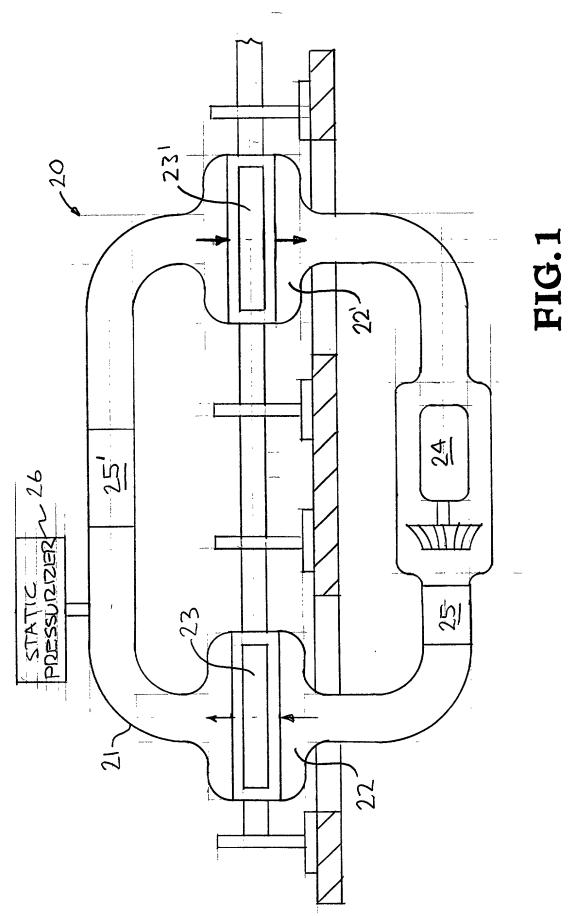
- 7. The laser method of claim 6 including the step of correcting thermally induced optical phase errors.
- 8. The laser method of claim 6 wherein said step of correcting thermally induced optical phase errors includes dividing the flowing lasing liquid into two equal lengths along the laser propagation direction, and placing the two sections in series in the optical laser cavity with the fluid flows arranged in opposite directions.

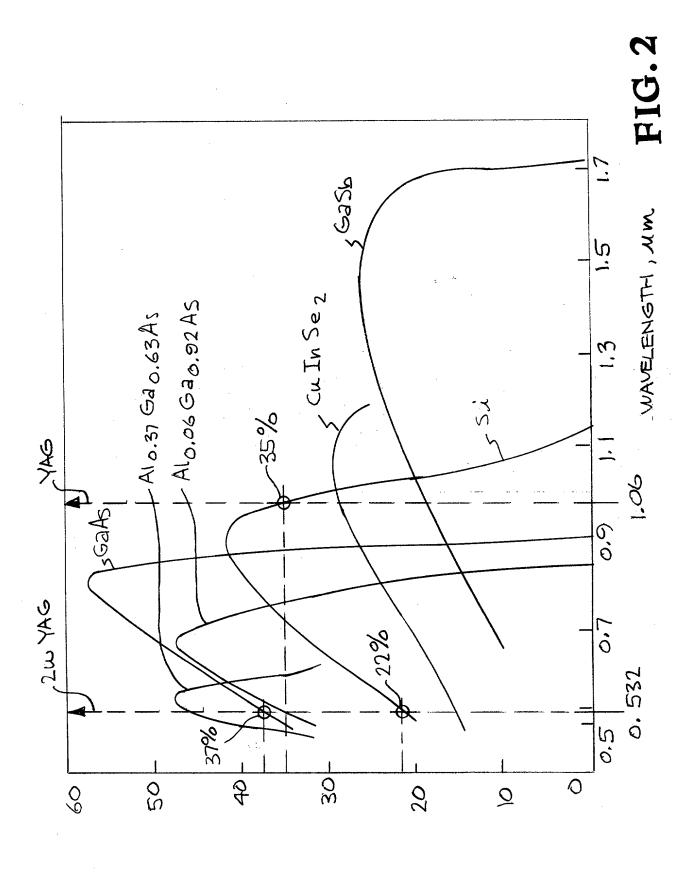
- 9. A laser system, comprising:
- an optical cavity,
- a diode pumping device within said optical cavity,
- a lasing liquid containing trivalent titanium ions dissolved in a
- 5 liquid host within said optical cavity, and

a circulation system that provides a closed loop for circulating said lasing liquid into and out of said optical cavity, said circulation system including a pump and a heat exchanger.

## ABSTRACT OF THE DISCLOSURE

A laser having a lasing chamber and a semiconductor pumping device with trivalent titanium ions dissolved in a liquid host within the lasing chamber. Since the host is a liquid, it can be removed from the optical cavity when it becomes heated avoiding the inevitable optical distortion and birefringence common to glass and crystal hosts.





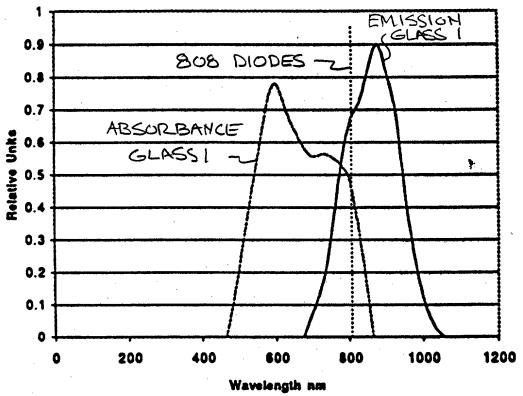


FIG. 3A

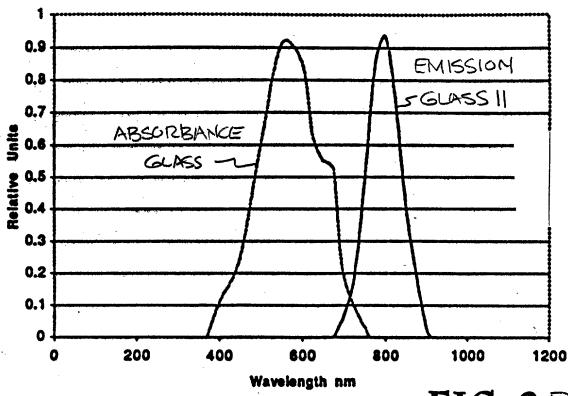


FIG.3B

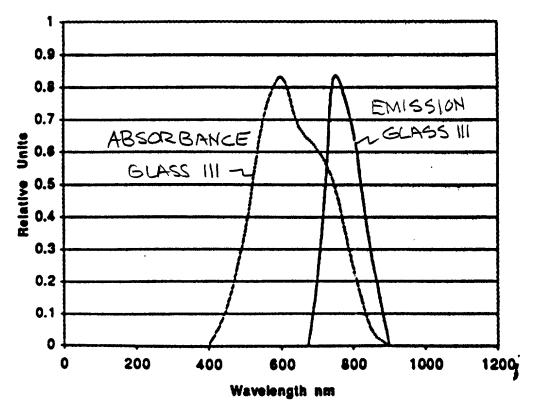


FIG. 3C

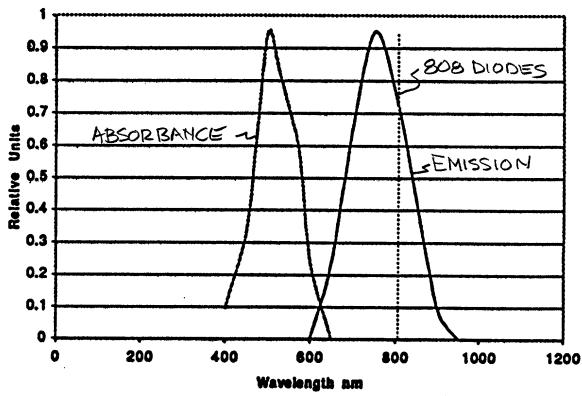


FIG.3D

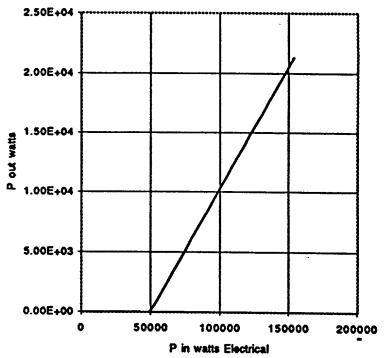


FIG. 4A

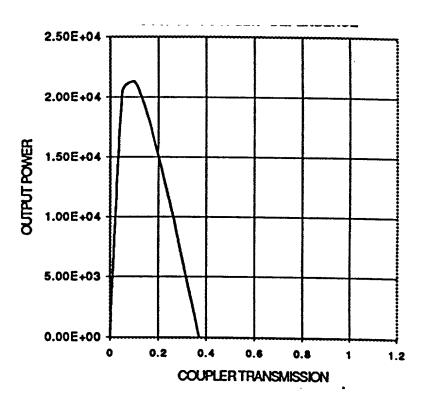


FIG.4B

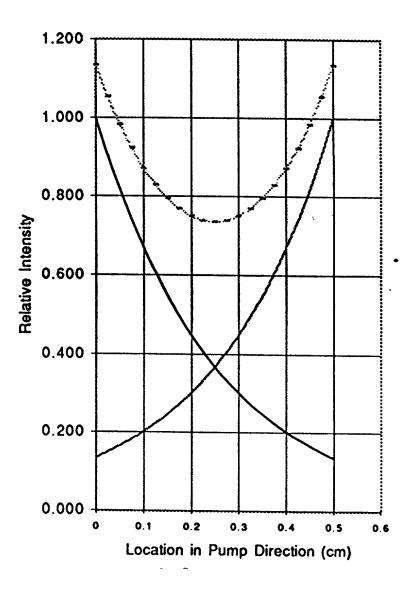


FIG. 4C

# COMBINED DECLARATION AND POWER OF ATTORNEY

■ Declaration submitted with Initial Filing			ney Docket: IL-10680 cant: Earl R. Ault
☐ Declaration submitted after Initial Filing (surch	narge	Serial	
(37 CFR 1.16(e)) requir	ed)		
As a below named invento	r(s), I (we) he	reby declare that:	
My (Our) residence, (our) name(s).	post office add	dress and citizenship(s)	are as stated below next to my
original, first and joint inverclaimed and for which a pat HAVING A TRIVALENT	ntor (if plural n ent is sought o TITANIUM	names are listed below) in the invention entitled	one name is listed below) or an of the subject matter which is HIGH POWER LASER
the specification of which (o X is attached hereto PCT International Applicational was amended on	was filed on Number		ited States Application Number or
			and the contents of the above-amendment referred to above.
I (We) acknowledge defined in 37 CFR 1.56.	the duty to dis	close information which	h is material to patentability as
foreign application(s) for pa application which designate below and have also identifi	tent or invento d at least one c ed below, by c ny PCT interna	r's certificate, or 365(a) country other than the Uhecking the box, any for	S.C. 119(a)-(d) or 365(b) of any of any PCT international inited States of America, listed breign application for patent or ang a filing date before that of the
Prior Foreign Application(s)	)		Priority Not Claimed
(Application Number)	(Country)	(Foreign Filing Date)	_ <b>_</b> ) 
(Application Number)	(Country)	(Foreign Filing Date)	
I (We) hereby claim application(s) listed below:	the benefit und	der 35 U.S.C. 119(e) of	any United States provisional
Application Serial No.	Fili	ng Date	

I (We) hereby claim the benefit under 35 U.S.C. 120 of any United States applications(s), or 365(c) of any PCT international application designating the United States of America, listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States or PCT international application in the manner provided by the first paragraph of 35 U.S.C. 112, I acknowledge the duty to disclose information which is material to patentability as defined in 37 CFR 1.56 which became available between the filing date of the prior application and the national or PCT international filing date of this application.

Application Serial No.	Filing Date	Status
		I (we) hereby appoint the following
therewith, in any patent office		nd to transact all business connected
Names		ration No.
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Alan H. Thompson	29,9	981
Christopher J. Horgan	40,3	394
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I (We) hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under 18 U.S.C. 1001 and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

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